

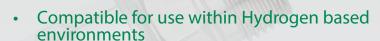
Hispec[®] HI2000H

Hydrogen Compatible High **Precision Pressure Transducer**









- High accuracy and performance
- Tested to ISO 11114-2:2017 according to EC79/2009 and EU406/2010
- Silicon-on-Sapphire sensor technology for outstanding performance
- Pressure ranges to 1,500 bar (20,000 psi)
- Specialist titanium alloy sensor for excellent chemical compatibility
- High thermal stability over wide operating temperature
- ATEX/IECEx option available (includes M1 for mining applications) for mV version
- **TEDS** Version available













Hispec * HI2000H Hydrogen Compatible High Precision Pressure Transducer



Description

The HI2000H high precision transducer is designed with state of the art Silicon-on-Sapphire sensor technology, offering levels of accuracy and performance previously unobtainable or prohibitively expensive. With operating ranges up to 1,500 bar the suitability of the material for use with hydrogen is confirmed following compatibility testing based on ISO 1114-2:2017 according to the European Regulations EC 79/2009 and EU 406/2010.

The unique Silicon-on-Sapphire sensor technology provides outstanding performance and gives excellent stability over a wide temperature range. The advanced sensor design consists of a piezoresistive silicon strain gauge circuit, which is epitaxially grown onto the surface of a sapphire diaphragm to form a single crystalline structure. The sapphire sensor element is then molecularly bonded to a Titanium alloy sub-diaphragm. This enables the sensor to endure higher over- pressures and provides superb corrosion resistance. The sensor exhibits

virtually no hysteresis and excellent long-term stability. With outstanding insulation properties, the sapphire substrate allows the sensor to operate over a very wide temperature range without loss of performance.

ATEDS (Transducer Electronic Data Sheet) version is available. A TEDS contains the critical information needed by an instrument or measurement system to identify, characterize, interface, and properly use the signal from an analog sensor. IEEE 1451.4 defines the method of encoding TEDS information for a broad range of senor types and applications.

Applications include aerospace, laboratory and test, oil and gas monitoring equipment (down-hole) and subsea. Available in pressure ranges from 0-500 mbar to 0-1,500 bar and with electrical outputs of 10 mV/V, 0-5 dc and 0-10 Vdc.

An optional ATEX and IECEx approved version of this product is available for explosion protection for flammable gases (zone 0), dusts (zone 20) and mining areas (group I MI)

Dim. A

80

95

HI2000

HI2010

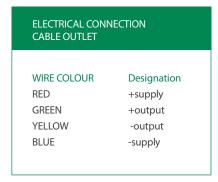
HI2001/2

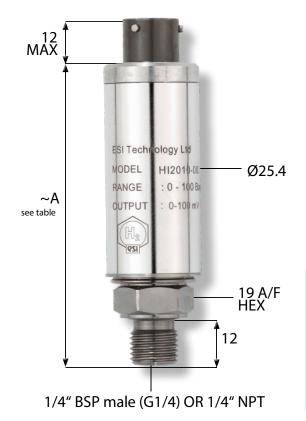
HI2011/12 95

Dimensions

(in mm)

ELECTRICAL C MIL-C-26482	ONNECTION
Pin.	Designation
A	+supply
В	+output
С	-output
D	-supply
E	N/C
F	N/C







Technical Data

Туре	HI2000/HI2010	HI2xx1/HI2xx4	HI2xx2/ HI2xx5			
Sensor Technology:	Silicon-on-Sapphire (SoS)					
Output Signal:	10 mV/V (4 wire)	0 – 5 V (4 or 3 wire)	0 – 10 V (4 or 3 wire)			
Supply Voltage:	10 VDC (5 – 15V)	13 – 30 VDC	13 – 30 VDC			
Pressure Reference:	Gauge					
Protection of Supply Voltage:	n/a Protected against supply voltage reversal up to 50 V (amplified versio					
Standard Pressure Ranges (bar):	0 – 1 bar Vac; 0 – 1 bar; 0 – 10 bar; 0 – 25 bar; 0 – 100 bar; 0 – 250 bar; 0 – 400 bar; 0 – 600 bar; 0 – 1,000 bar; 0 – 1,500 bar (other ranges available)					
Standard Pressure Ranges (psi):	0-30 in Hg; 0-15 psi; 0-150 psi; 0-300 psi; 0-1,500 psi; 0-3,000 psi; 0-6,000 psi; 0-10,000 psi; 0-15,000 psi (other ranges available)					
Overpressure Safety:	4x for 0.5 bar range; 2 x for ran	nges 1 bar to 600 bar; 1.5x for 1,000 bar r	ange; 1.1x for 1,500 bar range			
Load Driving Capability:	10 mV/V: n/a; 0 -	- 5 V: max. load RL > 5 KΩ; 0 – 10 V: max.	load RL $> 10~\text{K}\Omega$			
Accuracy NLHR:		≤ ±0.1 % of span BFSL				
Zero Offset and Span Tolerance:	±0.5 %F	S at room temperature (HI2000/HI2010:	±1 mV)			
Operating Ambient Temperature:		-40 °C to +85 °C (-40 °F to +185 °F)				
Operating Media Temperature:		-50 °C to +125 °C (-58 °F to +257 °F)				
Storage Temperature:	+5 °C to +40	0°C (+41°F to +104°F) Recommended B	est Practice			
Temperature Effects:	±1.0 %FS total error band for -20	°C to +70 °C. Typical thermal zero and s	span coefficients ±0.005 %FS/ °C			
ATEX/IECEx Approval Option (mV/V version only):	Ex II 1 G Ex ia IIC T4 Ga (zone 0) Ex II 1 D Ex ia IIIC T135 °C Da (zone 20) Ex I M 1 Ex ia I Ma (group 1 M1)	n/a	n/a			
ATEX/IECEx Safety Values:	Ui = 28 V Ii = 119 mA Pi = 0.65 W Li = 0.1 μH Ci = 0 Temperature Range = -20 °C to +70 °C Max. cable length = 50 m	n/a	n/a			
TEDS Version:	IEEE 1451.4 Sensor TEDS (contact sales for more information)					
Electromagnetic Compatibility:	Emissions: EN61000-6-4; Immunity: EN61000-6-2; Certification: CE Marked					
Insulation Resistance:		> 100 MΩ @ 50 VDC				
Response time 10-90 %:		1 mS				
Wetted Parts:		Titanium Alloy				
Pressure Media:	Hydrog	en and all fluids compatible with Titaniu	m alloy			
Pressure Connection:	1/4″BSP ma	ale (G1/4) or ¼"NPT male; other options	available			
Electrical Connection:		l, conductor size 7/0.1 mm. HI201x: MIL- ot included: mating connector type MS:				
Net. Weight (Kg):		0.1 Kg				



Order Matrix

Output	Electrical Connector	Wires	Туре	Options	Pressure Range	Process Connection
10 \/\//	Cable outlet 1m PTFE	4	HI2000H			
10 mV/V	MIL-C-26482 6 pin bayonet	4	HI2010H			
Cable outlet 1m PTFE 0-5 V MIL-C-26482 6 pin bayone	Cable outlet 1m PTFE	4	HI2001H			
		3	HI2004H			
	MIL C 20402 Curin bassarat	4	HI2011H			
	wiit-C-20482 o pin bayonet	3	HI2014H			
	Cable outlet 1m PTFE	4	HI2002H			
0.101/		3	HI2005H			
0-10 V	MIL C 20402 Curin become	4	HI2012H			
	MIL-C-26482 6 pin bayonet	3	HI2015H			
Electrical Conr	nection/Options					
No special opt	ion required			-		
No special opt	.oequieu					
	ertified (HI2000 & HI2010 only)			EXH (HI2000 and HI2010 only)		
ATEX/ IECEx ce	ertified (HI2000 & HI2010 only)					
ATEX/ IECEx ce	ertified (HI2000 & HI2010 only)					
ATEX/ IECEx ce Pressure Rang 0-1 barVac	ertified (HI2000 & HI2010 only)				V001	
ATEX/ IECEx ce Pressure Rang 0-1 barVac 0-1 bar	e in bar (0-15 psi)				0001	
Pressure Rang 0-1 barVac 0-1 bar 0-10 bar	e in bar (0-15 psi) (0-150 psi)				0001 0010	
Pressure Rang 0-1 barVac 0-1 bar 0-10 bar 0-25 bar	e in bar (0-15 psi) (0-150 psi) (0-300 psi)				0001 0010 0025	
Pressure Rang 0-1 barVac 0-1 bar 0-10 bar 0-25 bar	(0-150 psi) (0-1,500 psi)				0001 0010	
Pressure Rang 0-1 barVac 0-1 bar 0-10 bar 0-25 bar 0-100 bar	(0-15 psi) (0-150 psi) (0-300 psi) (0-3,000 psi)				0001 0010 0025	
Pressure Rang 0-1 barVac 0-1 bar 0-10 bar 0-25 bar 0-100 bar 0-250 bar	(0-150 psi) (0-1,500 psi)				0001 0010 0025 0100	
Pressure Rang 0-1 barVac 0-1 bar 0-10 bar 0-25 bar 0-100 bar 0-250 bar 0-400 bar	(0-15 psi) (0-150 psi) (0-300 psi) (0-3,000 psi)				0001 0010 0025 0100 0250	
Pressure Rang 0-1 barVac 0-1 bar 0-10 bar 0-25 bar 0-100 bar 0-250 bar 0-400 bar	(0-15 psi) (0-150 psi) (0-300 psi) (0-3,000 psi) (0-5,800 psi)				0001 0010 0025 0100 0250 0400	
ATEX/ IECEx ce	(0-15 psi) (0-150 psi) (0-300 psi) (0-1,500 psi) (0-3,000 psi) (0-5,800 psi) (0-8,700 psi)				0001 0010 0025 0100 0250 0400	
Pressure Rang 0-1 barVac 0-1 bar 0-10 bar 0-25 bar 0-100 bar 0-250 bar 0-400 bar 0-600 bar 0-1,000 bar	(0-15 psi) (0-15 psi) (0-150 psi) (0-300 psi) (0-3,000 psi) (0-3,000 psi) (0-5,800 psi) (0-8,700 psi) (0-14,500 psi) (0-14,500 psi)				0001 0010 0025 0100 0250 0400 0600 1000	
Pressure Rang 0-1 barVac 0-1 bar 0-10 bar 0-25 bar 0-100 bar 0-250 bar 0-400 bar 0-600 bar 0-1,000 bar	(0-15 psi) (0-150 psi) (0-150 psi) (0-300 psi) (0-3,000 psi) (0-5,800 psi) (0-8,700 psi) (0-14,500 psi) (0-20,000 psi)				0001 0010 0025 0100 0250 0400 0600 1000	AB

For options not listed please contact the sales team

DISCLAIMER: ESI Technology Ltd operates a policy of continuous product development. We reserve the right to change specification without prior notice.All products manufactured by ESI Technology Ltd are calibrated using precision calibration equipment, traceable to national measurement standards.

HI2000H0600AB

Order Number Example